

## multi dimensional translation stage

# PXY 201

- wide range of sub-nm step motion
- integrated capacitive direct metrology
- excellent trajectory trueness
- 30x30 mm<sup>2</sup> clearance
- high load capability
- internal damping system
- advanced reliability and robustness

#### applications:

- nanopositioning
- micro scanning
- scanning microscopy
- surface analysis
- metrology and alignment

#### Concept

*piezosystemjena* introduces an XY plane nanopositioning and microscanning stage featuring a wide center clearance.

Its offered travel and scanning range is controlled by a direct measuring high resolution metrology.

Outstanding trajectory trueness even at higher loads and appropriate stiffness are major advantages.

Vacuum and cryogenic performances are available on demand as well, body material variations of invar, superinvar, aluminum or titanium too.

#### Specials

The PXY 201 CAP and PXY 201 CAP DIG are equipped with an integrated direct high resolution measuring capacitive feedback sensor. In combination with the complementary amplifier/ controller from *piezosystem jena* any creep and hysteresis avoided. Furthermore are stability, supreme position repeatability linearity. and accuracv are achieved. piezosystemjena digital amplifier/controllers in closed loop operation additionally feature in-situ and dynamic set up of PID parameters, slew rate and notch-filter bandwidth. So you can match the electrical parameters depending on the current load scenario and, through trial and error, optimize the performance during system operation.

Because of the frame design of the guidance the stage is very robust against high loads and lateral mishandling too.

### fig.: PXY 201 CAP

#### Mounting/Installation

The center symmetric tapped hole raster within bottom and top plate allows easy mounting of the nanopositioning and microscanning stage to the ground and parts on it. Its robustness causes no need of additional mounting tools.







#### **Technical Data:**

series		unit	PXY 201	PXY 201 CAP	PXY 201 CAP DIG	
part. no.	art. no.		-	T-228-00	T-228-06	T-228-06D
axis		-	Χ, Υ	Χ, Υ	Χ, Υ	
motion open loop (±10%)*		μm	250	250	250	
motion closed loop (±0,2%)*			μm	200	200	200
capacitance (±20%)**		μF	2 x 3.5	2 x 3.5	2 x 3.5	
feedback sensor			-	-	capacitive	capacitive
resolution***			nm	0.35	1	1
free aperture		mm²	30 x 30	30 x 30	30 x 30	
typ. repeatability		nm	-	±10	±10	
typ. nonlinearity		%	-	0.02	0.02	
max. load		Ν	100	100	100	
push/pull force capacity		Ν	100 / 20	10 / 10	10 / 10	
resonant frequency (X/Y/Z)		Hz	220 / 170 / 1000	220 / 170 / 1000	220 / 170 / 1000	
additional load = 50g		Hz	165 / 135	165 / 135	165 / 135	
additional load = 100g		Hz	145 / 120	145 / 120	145 / 120	
additional load = 300g		Hz	110 / 100	110 / 100	110 / 100	
stiffness		N/µm	0.35 / 0.35 / 5.0	0.35 / 0.35 / 5.0	0.35 / 0.35 / 5.0	
rotational error	roll		µrad	3	3	3
	pitch		µrad	3	3	3
	yaw		µrad	3	3	3
dimensions (I x w x h)		mm³	3	3	3	
voltage range		V	-20130	-20130	-20130	
voltage		voltage	-	LEMO	LEMO	D-sub
connector		sensor	-	-	LEMO D-sub	
temperature range		°C	-20 +80			
material		-	stainless steel/aluminum			
weight		g	300	370	370	

typical value measured with NV 40/3 amplifier

typical value for small electrical field strength
\*\*\* The resolution is only limited by the noise of the power amplifier and metrology.

#### recommended configurations:

actuator amplifier / controller	PXY 201 NV 40/3	T-228-00 E-101-20
actuator amplifier / controller	PXY 201 CAP DIG NV 40/3 CLE	T-228-06D E-101-23
actuator amplifier / controller	PXY 201 CAP ENT 40/20 (230V / 115V) 2 x ENV 40 CAP	T-228-06 E-103-13/E-103-14 E-103-60
casing	63 TE housing 19"	E-103-90
actuator	PXY 201 CAP DIG	T-128-06D
amplifier / controller	2 x 30DV50	E-754-300

Please pay attention to our "notes for mounting", which are available as download on our homepage.





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